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ANALYSIS, EVALUATION, AND OPTIMIZATION OF BIO-MEDICAL THERMO-RESISTIVE MICRO-CALORIMETRIC FLOW SENSOR USING AN ANALYTICAL APPROACH

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Abstract

Sensitive MEMS-based thermal flow sensors are the best choice for monitoring the patient's respiration prompt diagnosis of breath disturbances. In this paper, open space micro-calorimetric flow sensors are investigated as precise monitoring tools. The differential energy balance equation, including convection and conduction terms, is derived for thermal analysis of the considered sensor. The temperature-dependent thermal conductivity of the thin silicon-oxide membrane layer is considered in the energy balance equation. The derived thermal non-linear differential equation is solved using a well-known analytical method, and a finite-element numerical solution is used for the confirmation. Results show that the presented analytical model offers a precise tool for evaluating these sensors. The effects of flow and thin membrane film parameters on thermo-resistive micro-calorimetric flow sensors' performance and sensitivity are evaluated. The optimization has been performed at different flow velocities using a genetic algorithm method to determine the optimum configuration of the considered flow sensor. The geometrical parameters are selected as a decision variable in the optimization procedure. In the final step, using optimization results and curve-fitting, the expressions for the optimum decision variables have been derived. The sensor's optimum configuration is achieved analytically based on flow velocity with the analytical terms for optimum decision variables.

Keywords: thermo-resistive, micro-calorimetric, sensor, temperature, variable conductivity, analytical solution, optimization.

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1. Introduction

Fluid flow measurement is one of the essential tools for analyzing various systems. Therefore, the accuracy of fluid flow measuring instruments is crucial and has been considered by various researchers. Among the conventional fluid flow measuring tools there are microflow sensors which can be divided into thermal and non-thermal ones. The thermal flow sensors category shows

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great applicability in microfluidic devices, medical ventilation, spacecraft propulsion systems, and environmental monitoring. It has three sub-categories: hot wire/hot film, calorimetric, and flight time [1,2].

Prompt diagnosis of breath disturbances is one of essential requirements and preconditions for the treatment procedure. Performing this medical diagnosis requires monitoring the patient's respiration, and this monitoring requires appropriate sensors. The best choice is a sensitive MEMS-based thermal flow sensor with a fast response time (1 kHz) and low power consumption. Micro-fabricated devices' valuable characteristics such as high sensitivity, accuracy and precision, low power consumption, and small size have provided a better patient outcome and lower healthcare costs. Most applications of these sensors are in measuring physical parameters such as flow pressure. With these sensors' we can monitor blood flow, pressure measurement (such as intravascular blood pressure), microsurgery, bladder, cerebrospinal fluid pressure measurement, and drug delivery [3]. Different researches have been performed on modeling, designing, manufacturing, and optimizing fluid flow measurement tools. Some of these researches are considered in the flowing section.

Wei et al. [1] presented a simple one-dimensional analytical model for a thermo-resistive micro calorimetric flow (TMCF) sensor. They used CFD simulations and experimental data to validate the model and studied the effect of key design parameters on the sensor performance. Wei et al. [2] presented both theoretical and experimental investigation into TMCF sensors fabricated with CMOS MEMS Technology. They analyzed a general one-dimensional model to predict the TMCF sensor characteristics with two types of packaging, *i.e.*, channel and openspace types. They optimized the TMCF sensor's design by scaling the sensor output, sensitivity, and power consumption value. They designed and fabricated three TMCF sensors by using a 0.35 µm 2P4M CMOS microelectromechanical systems technology. Ferdous et al. [4] optimized a micro-machined thermal flow rate sensor. They tried to achieve high sensitivity and low power consumption through employing a large thermal conductivity substrate. They found that the sensor has a more considerable sensitivity in the velocity range up to 1 m/s. Wei et al. [5] analyzed a wafer-level encapsulated Thermo-Resistive Micro Calorimetric Flow (TMCF) sensor. Gas nitrogen was selected for the fluid. They achieved a normalized sensitivity of 112.4 mV/(m/s)/mW for a pulse-operated TMCF sensor in the constant temperature difference mode. They concluded that the sensors could be used for IoT technology in smart buildings. Wei et al. [6] proposed a new one-dimensional TMCF sensor model for moist airflow with temperature-dependent thermophysical properties. They fabricated a sensor with a superior sensitivity of 0.543 V/(m/s). Franz et al. [7] analyzed micro machined calorimetric flow sensors by FEM simulations. Dumstorff et al. [8] presented a novel packaging method to analyze a membrane-based thermal flow sensor. To avoid turbulence and reduction in channel cross-section or sensitivity, they placed a flow sensor in a channel in different step arrangements. Arpys et al. [9] used COMSOL Multi-physics to simulate a thermal transport-based flow sensor. They found that the maximum temperature difference between the two temperature sensors is about 7°C; these results proposed an essential characteristic of the device's operating range. Wei et al. [10] designed and fabricated a low-cost TMCF sensor using a commercial 0.35 µm 2P4M CMOS MEMS technology. They used the configured CTD mode circuit and minimized the inconsistent sensor output caused by ambient temperature variation. Wei et al. [11] studied the packaging effect (including two types of sensor packaging designs: S-type and E-type) on CMOS Thermo-Resistive Micro Calorimetric Flow performance sensors. They performed CFD simulations and achieved a flow regime map that showed the critical boundary curve for the flow separation of CMOS TMCF sensors. Lammerink et al. [12] presented a micro-liquid flow sensor with high sensitivity. They created a sensor behavior analytical model. Dinh et al. [13] reviewed the thermoresistive effect fundamentals in





metals and semiconductors. They discussed the influence of fabrication and design parameters on thermoresistive sensitivity. Balakrishnan et al. [14] proposed an analytical model for a released microscale heater made of 3C-SiC thin films. They showed the potential of thermal sensors in portable applications with low power consumption (0.18 mW) at 310 K. Dijkstra et al. [15] studied a calorimetric miniaturized flow sensor with a thermally isolated freely suspended silicon-rich silicon-nitride microchannel directly below the substrate surface. Haneveld et al. [16] presented the modeling, design, and realization of micromachined Coriolis mass flow sensors. They showed that the sensor measures true mass flow of water, ethanol, white gas, and argon. Nguyen [17] presented a review of the micromachined flow sensors. Van Kuijk et al. [18] presented a micro mechanically fabricated thermal flow sensor. They analyzed the ability of an artificial neural network to learn to discriminate between the flow velocity and flow properties. Nguyen [19] presented a unified theory of different measurement concepts of a thermal flow sensor. He presented the experimental results of the sensor prototype. Issa et al. [20] introduced a theoretical model for the thermal flow sensor's response time. They found that results agree with experimental measurements and suggested the response time depends on the velocity and the sensor geometry. The evolutionary procedure has been used for material parameter identification in modeling material behavior of soft tissues by Franulović et al. [21]. This paper gives a detailed theoretical basis to provide inverse modeling and apply the presented method to the material models calibration and validation of the chosen parameters set. For the solution of the differential equation, different methods have been used in the researches. Ghalambazet et al. [22] presents an analytical solution for the buckling analysis of cantilever nanoactuators immersed in an electrolyte using the Duan-Rach Modified Adomian Decomposition Method. In another research, Noghrehabadi et al. [23] used the ADM–Padé technique for the electrostatic pull-in instability of nano cantilever actuators. Xu et al. [24] present a 3D integrated molybdenum thermoresistive micro-calorimetric flow sensor. They found that this model would be an efficient tool for the design and optimization of high-performance system-on-chip calorimetric flow sensors. Ejeian et al. [24] present an overview of the design and development of microelectromechanical system (MEMS) - based flow sensors. They found that the MEMS flow sensors can be generally categorized into three main types, namely thermal sensors, piezoresistive sensors, and piezoelectric sensors. Algamili et al. [25] reviewed the recent developments of standard actuation and sensing mechanisms. The real-life applications, the featured principles of actuating and sensing mechanisms have been discussed by them.

Most studies have been based on computational fluid dynamics and experimental data, and most one-dimensional models are also presented using experimental results. Since limited laboratory conditions lead to the extraction of results for some instances, it seems necessary to use an alternative method that can be more inclusive and, at the same time, can use materials with variable properties. The present study aims to derive a complete analytical model for sensor behavior. The current paper considers the thermal analysis and optimization of the Thermo-Resistive Micro-Calorimetric Flow Sensor using the analytical method. The energy balance equation is derived for the silicon-dioxide membrane thin layer and the thermal boundary layer around the membrane in the first step. Then, silicon dioxide's temperature-dependent thermal conductivity is applied to derive a differential energy balance for the membrane layer. For the derived thermal non-linear differential equation solution, the precise analytical method, the Differential Transformation Method (DTM), has been used. For the analytical solution confirmation, the non-linear differential equation has been solved again with the finite-element method. Sensitivity analysis has been performed to analyze the effects of operational and geometrical parameters on the thermal characteristics of the sensor considered. In these sensors, the flow rate is calculated based on temperature differences between two positions of the silicon diox-



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ide membrane layer. The optimization has been performed at different flow velocities using a genetic algorithm to determine the optimum configuration of the thermo-resistive flow sensor. The temperature difference ratio between the upstream and downstream flows has been selected as an objective function in the optimization procedure. The geometrical parameters have been chosen as the decision variables. Optimal flow sensor configuration at various flow velocities has been determined through genetic algorithm optimization. The analytical expressions for the optimum decision variables have been derived using the curve-fitting method in the final step. Optimum design of a thermo-resistive micro-calorimetric flow sensor can be achieved analytically based on flow velocity with the analytical expressions for optimum decision variables.

2. Modeling

2.1. Description of the problem

In this research, the *Thermo-Resistive Micro-Calorimetric Flow* (TMCF) sensor analysis using an analytical method, optimization based on analytical solution, and finally, providing analytical correlation to find the optimal configuration is considered. As mentioned before, *Thermo-resistive micro calorimetric flow sensors* (TMCF) can be divided into open-space and channel-type categories, and in the current paper, the open-space type is considered. A schematic of a TMCF sensor is presented in Fig. 1. A TMCF sensor generally consists of a micro-heater at the center of a thin film and two thermo-resistive sensors that are symmetrically located upstream and downstream with Tu and Td's temperature, respectively. The thin film is supported by massive silicon (Si) substrate.



Fig. 1. Schematic of the thermo-resistive micro calorimetric flow sensor.



The temperature difference between upstream and downstream sensors is related to convective heat transfer and input flow velocity in fluid flow. Therefore, the temperature difference between the upstream and downstream sensors can be converted to an electrical signal, and mass flow measurement is performed. The geometrical parameter and sensor position dimensions and the heat transfer element are shown in Fig. 2, and the detailed data are presented in Table 1. With the applied interface circuit for the upstream and downstream thermoresistive sensors, the electrical output of the TMCF sensor is monitored as a linear function of the thermal output.



Fig. 2. Schematic of thermo-resistive micro calorimetric flow sensor dimensions.

Parameter	Value
s (µm)	750
<i>L</i> (µm)	300
W (µm)	50
<i>D</i> (µm)	120
<i>h</i> (μm)	150
<i>t</i> (µm)	4

Table 1. Thermo-resistive micro calorimetric flow sensor dimensions [1].

2.2. Energy balance equation

For the energy balance formulation, the lumped parameter method was employed to describe the critical behavior of TMCF sensors. For example, in the steady-state condition, the sum of the inlet convective and conductive heat fluxes in a control volume is equal to the sum of the outlet heat fluxes as follows:

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$$\sum Q_{\rm in} - \sum Q_{\rm out} = 0, \tag{1}$$

$$Q_{f \cdot x}^{\text{cond}} + Q_{f \cdot x}^{\text{conv}} + Q_{s \cdot x}^{\text{cond}} + Q_{f 1 \cdot x}^{\text{cond}} = Q_{f \cdot y}^{\text{cond}} + Q_{f 1 \cdot y}^{\text{cond}}.$$
(2)

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The inlet and outlet conductive heat fluxes can be calculated as follows [2]:

$$Q_{s \cdot x}^{\text{cond}} = k_s \frac{\mathrm{d}^2 T(x)}{\mathrm{d}x^2} t \Delta x,\tag{3}$$

$$Q_{f \cdot x}^{\text{cond}} = \frac{1}{2} k_f \frac{\mathrm{d}^2 T(x)}{\mathrm{d}x^2} \Delta x \delta_{t \cdot x} , \qquad (4)$$

$$Q_{f\,1\cdot x}^{\text{cond}} = \frac{1}{2} k_{f\,1} \frac{\mathrm{d}^2 T(x)}{\mathrm{d}x^2} h \,\Delta x,\tag{5}$$

$$Q_{f \cdot y}^{\text{cond}} = k_f \frac{T(x)}{\delta_{t \cdot x}} \Delta x, \tag{6}$$

$$Q_{f1\cdot y}^{\text{cond}} = k_{f1} \frac{T(x)}{h} \Delta x.$$
⁽⁷⁾

Assuming a linear profile for flow velocity, the inlet convection heat flux for the open-space type sensor is expressed by [2]:

$$Q_{f \cdot x}^{\text{conv}} = \frac{\rho C_p U \delta_{t \cdot x}^2}{6\delta_x} \frac{\mathrm{d}T(x)}{\mathrm{d}x} \Delta x.$$
(8)

By substituting Equations (3–8) in Equation (2) and considering the averaged momentum boundary layer δ and thermal boundary layer δ_t , the general one-dimensional thermal differential equation for the TMCF sensors can be presented as below [2]:

$$\frac{\mathrm{d}}{\mathrm{d}x} \left[\left(k_s t + \frac{1}{2} k_f \,\delta_t + \frac{1}{2} k_{f\,1} h \right) \frac{\mathrm{d}T(x)}{\mathrm{d}x} \right] -\rho C_P U \beta \frac{\mathrm{d}T(x)}{\mathrm{d}x} - \left(\frac{k_f}{\delta_t} \right) (T(x) - T_a) = 0.$$
(9)

In this equation, the averaged momentum boundary layer and the thermal boundary layer are considered. The variation of thermal conductivity of silicon-dioxide membrane temperature is defined using Equation (10) [2]:

$$k_s = k_{0,s} \times (1 + \gamma \times (T - T_a)). \tag{10}$$

After some simplification, the final non-linear thermal differential equation is derived as below [2]:

$$\frac{\mathrm{d}}{\mathrm{d}x} \left[\left(\left(k_{0.s} \times \left(1 + \gamma \times \left(T - T_a \right) \right) \right) t \right) \frac{\mathrm{d}T(x)}{\mathrm{d}x} \right] + \left(\frac{1}{2} k_f \,\delta_t + \frac{1}{2} k_{f\,1} h \right) \frac{\mathrm{d}^2 T}{\mathrm{d}x^2} -\rho C_P U \beta \frac{\mathrm{d}T(x)}{\mathrm{d}x} - \left(\frac{k_f}{\delta_t} \right) \left(T(x) - T_a \right) = 0.$$
(11)

The packaged sensor type coefficient (β) is derived as below [2]:

$$\beta = \frac{\delta_t^2}{6\delta} \,. \tag{12}$$





The averaged momentum and thermal boundary layer along the thin film for the open-space type sensor can be calculated by Equations (13) and (14) [2]:

$$\delta_x = 4.64 \sqrt{\frac{\mu_f \left(x+s\right)}{\rho U}},\tag{13}$$

$$\delta_t = \zeta \delta; \qquad \zeta = \frac{1}{1.026} \Pr^{-1/3} \left[1 - \left(1 - \frac{L}{s} \right)^{3/4} \right]^{1/3}.$$
 (14)

The new variable (θ) is considered for the temperature parameter [2]:

$$\theta = T - T_a; \qquad \theta_h = T_w - T_a \,. \tag{15}$$

The final differential equation is derived as below [2]:

$$\frac{\mathrm{d}}{\mathrm{d}x} \left[\left((k_{0,s} \times (1 + \gamma \times \theta))t \right) \frac{\mathrm{d}\theta}{\mathrm{d}x} \right] + \left(\frac{1}{2} k_f \,\delta_t + \frac{1}{2} k_{f\,1} h \right) \frac{\mathrm{d}^2\theta}{\mathrm{d}x^2} -\rho C_P U \beta \frac{\mathrm{d}\theta}{\mathrm{d}x} - \left(\frac{k_f}{\delta_t} \right) \theta = 0.$$
(16)

The output thermal signal of the TMCF sensor can be determined as [2]:

$$\Delta \theta = \theta \left(W + D \right) - \theta (-W - D). \tag{17}$$

By differentiating the sensor output concerning the input fluid flow velocity, the mechanothermal sensitivity has been determined [2]:

$$S_m = \frac{\mathrm{d}\left(\Delta\theta\right)}{\mathrm{d}U} \,. \tag{18}$$

2.3. Boundary condition

For the solution of Equation (16), the temperature of the thin film at supporting ends is considered equal to the ambient temperature, and the microheater working temperature is assumed to be T_w . The temperature of the ends of the heater is used as another boundary condition based on the definition of an equation in terms of ambient temperature. These boundary conditions can be introduced with Equation (19) as below [2]:

$$\theta(-L) = 0;$$
 $\theta(-W) = \theta_h;$ $\theta(L) = 0;$ $\theta(W) = \theta_h.$ (19)

3. Method of solution

3.1. Differential transformation method

In this section, the generalized differential transformation method developed for the non-linear differential equation's analytical solution is presented. For example, the generalized differential transformation of the *n*-th derivative of function f(x) is as follows:

$$F_{\alpha}(k) = \frac{1}{\Gamma(\alpha k+1)} \left[(D_{x_0}^{\alpha})^k f(x) \right]_{x=x_0} \,.$$
(20)

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And the generalized differential inverse transformation of $F_{\alpha}(k)$ is defined as:

$$f(x) = \sum_{k=0}^{\infty} F_{\alpha}(k) (x - x_0)^{\alpha k}.$$
 (21)

The fundamental mathematical operations used in the generalized differential transformation method are listed in Table 2.

Original function	Transformed function
$f(x) = g(x) \pm h(x)$	$F_{\alpha}(k) = G_{\alpha}(k) \pm H_{\alpha}(k)$
f(x) = ag(x)	$F_{\alpha}(k) = aG_{\alpha}(k)$
$f(x) = g(x) \cdot h(x)$	$F_{\alpha}(k) = \sum_{l=0}^{k} G_{\alpha}(l) H_{\alpha}(k-l)$
$f(x) = g_1(x)g_2(x)g_2(x)\dots g_{n-1}(x)g_n(x)$	$F_{\alpha}(k) = \sum_{k_{n-1}=0}^{k} \sum_{k_{n-2}=0}^{k_{n-1}} \dots \sum_{k_{2}=0}^{k_{3}} \sum_{k_{1}=0}^{k_{2}} G_{1}(k_{1})G_{2}(k_{2}-k_{1})\dots$ $G_{n-1}(k_{n-1}-k_{n-2})G_{n}(k-k_{n-1})$
$f(x) = D^{\alpha}_{x_0} g(x)$	$F_{\alpha}(k) = \frac{\Gamma(\alpha(k+1)+1)}{\Gamma(\alpha k+1)} G_{\alpha}(k+1)$
$f(x) = (x - x_0)^{\gamma}$	$F_{\alpha}(k) = \delta\left(k - \frac{y}{\alpha}\right)$, where $\delta(k) = \begin{cases} 1 & \text{if } k = 0\\ 0 & \text{if } k \neq 0 \end{cases}$
$f(x) = D_{x_0}^{\beta} g(x)$	$F_{\alpha}(k) = \frac{\Gamma(\alpha(k) + \beta + 1)}{\Gamma(\alpha k + 1)} G_{\alpha}\left(k + \frac{\beta}{\alpha}\right)$
$\int_{x_0}^x g(t) \mathrm{d}t$	$F_{\alpha}(k) = \frac{\left(G_{\alpha}\left(k - \frac{1}{\alpha}\right)\right)}{\alpha k}, \text{ where } k \ge 1/\alpha$

Table 2. Fundamental	operations in the	Generalized	Differential	Transform	Method	[27]

3.2. Finite element method

For the analytical solution confirmation, the FlexPDE software package has been chosen as the numerical solving tool. FlexPDE is a general-purpose software package for obtaining numerical solutions to ordinary and partial differential equations based on the Finite Element Method. FlexPDE uses an Adaptive Mesh Refinement method. Once the initial mesh is constructed, FlexPDE estimates the solution error and refines the mesh as necessary to meet the target accuracy. Cells created by this adaptive refinement process can later be remerged. FlexPDE also automatically recognizes when a problem is non-linear and modifies its strategy accordingly. The solution method tries to decrease the gradient of an energy functional until minimum power is achieved (*i.e.*, the functional gradient goes to zero). The default strategy implemented in FlexPDE is frequently sufficient to determine a solution without user intervention.



4. Solution of the differential equation

This section applies the differential transformation to the governed non-linear differential equation (Equation (16)). Based on the DTM principles, the final transformed differential equation can be presented as below:

$$\sum_{n=0}^{k} (k+1-n)(k+2-n)\theta_{k+2-n}\theta_k + \sum_{n=0}^{k} (k+1-n)\theta_{k+1-n}(n+1)\theta_{n+1} + A(k+1)(k+2)\theta_{k+2} + B\sum_{n=0}^{k} (k+1-n)(k+2-n)\theta_{k+2-n}G_n - C\sum_{n=0}^{k} \sum_{m=0}^{n} (k+1-n)\theta_{k+1-n}H_{n-m}\delta_m - DD\sum_{n=0}^{k} (k+1-n)\theta_{k+1-n}H_n - E\sum_{n=0}^{k} \theta_{k-n}H_n - F\theta_k = 0,$$
(22)

where

$$A = \left(\frac{1}{\beta} + \frac{k_{f\,1}h}{2k_0\beta t}\right) \cdot B = \frac{2.32k_f\zeta}{k_0\beta t} \cdot C = \frac{0.7734\zeta^2 C_p\mu_f}{k_0\beta t} \cdot DD = Cs \cdot E$$
$$= \frac{0.2155172414k_f}{k_0\beta t\zeta} \cdot F = \frac{k_{f\,1}}{k_0\beta th}.$$
(23)

G and H are the differential transformation of $\sqrt{at+b}$ and $\frac{1}{\sqrt{at+b}}$ respectively. The DTM of the boundary condition can be evaluated as below:

$$\theta_0 = aa, \qquad \theta_1 = bb, \tag{24}$$

where aa and bb are auxiliary parameters and are calculated at the final step, with the solution procedure, the required coefficients are calculated as below:

$$\theta_2 = \frac{1}{2} \frac{-bb^2\sqrt{b} + C\,bb + DD\,bb + E\,aa + F\,aa\,\sqrt{b}}{aa\sqrt{b} + A\sqrt{b} + B\,b}\,,\tag{25}$$

$$\theta_{3} = -\frac{1}{12} (2C bb a B b + 2 DD bb a B b + 2E aa a B b + B b^{3/2} a F aa + C bb a aa \sqrt{b} + C bb a A \sqrt{b} + DD bb a aa \sqrt{b} + DD bb a A \sqrt{b} - 2E bb b^{2}B + E aa a A \sqrt{b} - 2F bb b^{5/2}B + 4bb b^{3/2} E aa + 4 bb b^{2} F aa - B b^{3/2} a bb^{2} - 4 C b DD bb - 2C b E aa - 2Cb^{3/2} F aa - 2DD b E aa - 2DD b^{3/2} F aa - 2E bb b^{3/2}A + E aa^{2}a \sqrt{b} - 2F bb b^{2}A + 8 bb^{2}b^{3/2}C + 8 bb^{2}b^{3/2}DD - 2bC^{2}bb - 2b DD^{2}bb - 6bb^{3}b^{2})/(bb b^{52}B + 2b^{5/2}A B + bb b^{2}aa + bb b^{2}A + b^{2}A aa + Bb^{5/2}aa + B^{2}b^{3} + b^{2}A^{2}).$$
(26)

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5. Optimization of the sensing element position

Achieving an optimal design to maximize sensor measurement accuracy is one of the most critical issues in designing thermo-resistive sensors. Increasing the accuracy of the sensors requires increasing the temperature difference. This paper aims to achieve an optimal analytical design to guarantee the maximum temperature difference in the thermo-resistive sensor. For this purpose, the genetic algorithm optimization method (optimization toolbox in MATLAB) [28] has been used. The objective function is the temperature difference between the upstream and downstream flow sensors that should be maximized:

Objective Function =
$$\frac{\theta_{\text{upper}} - \theta_{\text{lower}}}{\theta_h}$$
. (27)

The decision variables are the geometric parameter listed in Table 3.

Parameter	Symbol	Range
Sensor distance from the heater	D	100–150 μm
Partially heated length	L	200–400 µm
Heater temperature	Th	30–70 K
Length of heater	W	30–70 µm
Cavity height	h	100–200 µm
Length of the bare TMCF sensor chip	s	600–800 μm

Table 3. Decision variable used in the optimization procedure.

The main tuning parameters for the genetic algorithm optimization are as below:

- Population size: 700.
- Maximum number of generations: 400.
- Probability of crossover: 75(%).
- Probability of mutation: 1(%).
- Number of crossovers: point 2.
- Selection process: Tournament (size = 2).

The optimization process for different flow velocity values (U) is performed to achieve a flexible optimal design. Finally, an analytical correlation for the optimal geometric parameters in flow velocity is created using the curve fitting.

6. Results and discussion

A comparison of the current analytical result, numerical solution (FlexPDE), and reference [2] is shown in Fig. 3. The authors have concluded that the one-dimensional model results were the same as the experimental results in this reference. The comparison shows that the analytical results are in excellent agreement with the numerical solution and reference [2]. Also, the evaluation of modeling error in Table 4 shows that the model error rate is in a suitable range. Furthermore, the result shows that the output temperature difference ($\Delta\theta$) increased with the fluid flow velocity increments. Therefore, the 1D simulated model of TMCF sensors with a fitting function agrees with the numerical solution and previous studies. The device geometry and parameters are considered the same as the reference for comparison. Consequently, the 1D model with a correction fitting function can be considered as a semi-empirical TMCF model.



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Fig. 3. Thermo-resistive micro calorimetric flow sensor modeling verification.

U	Analytical Solution	Numerical Solution	Relative Error	U	Analytical Solution	Numerical Solution	Relative Error
0.5	0.052605762	0.052702202	0.183	5.5	0.185516498	0.185611463	0.051
1	0.082161081	0.082174754	0.017	6	0.191453366	0.191546944	0.049
1.5	0.103503457	0.103559132	0.054	6.5	0.197159947	0.197227616	0.034
2	0.119959534	0.119985286	0.021	7	0.202374453	0.202461821	0.043
2.5	0.133456978	0.133463549	0.005	7.5	0.206770241	0.20685421	0.041
3	0.145159343	0.145201262	0.029	8	0.210801799	0.210862036	0.029
3.5	0.15992914	0.159942336	0.008	8.5	0.214781131	0.214781474	0.000
4	0.162628312	0.162647339	0.012	9	0.218526368	0.218529448	0.001
4.5	0.171170781	0.171237896	0.039	9.5	0.222249377	0.222252395	0.001
5	0.179418969	0.179447689	0.016	10	0.225930261	0.225947399	0.008

Table 4. Comparison of analytical and numerical solution.

The variation of sensitivity (S_m) with the fluid flow velocity is presented in Fig. 4. The result shows that sensitivity decreased with the fluid flow velocity increments, and this status indicates a trade-off between the output amplitude and sensitivity. Thus, a sensitive TMCF sensor can be achieved for a small input flow, allowing micro calorimetric flow sensors to be applied in low flow velocity measurements.



Fig. 4. Thermo-resistive micro calorimetric flow sensor sensitivity.

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Investigating the effect of different parameters on sensor performance shows that the film thickness, cavity height, and heater-sensors distance have the most impact on temperature difference and therefore have more effect on sensor sensitivity. On the other hand, based on Equation (8) the convective heat transfer depends on the velocity and working fluid property. And by changing the velocity of the fluid, the convective heat transfer shows its effect on the temperature distribution in the sensor. Therefore, in this section, the impact of these parameters is investigated with several figures. Fig. 5 presents that a smaller film thickness can lead to higher $\frac{\Delta \theta}{\theta_h}$ in the TMCF sensor. Because of increasing the film thickness, the heat leakage is increased by increasing the conduction heat transfer, and as a result, the temperature decreases. It should be noted that complex technology is required to fabricate these thin films. Fig. 5 shows that the temperature difference increases with the velocity increment at the different film thicknesses. This is because the convective heat transfer from the free stream flow is increased. Therefore, at low velocity, the accuracy of the measurements will be higher.



As shown in Fig. 6, the temperature difference does not change significantly at different cavity heights (at the bottom) at a specific velocity. This is because increasing the cavity heights (h) increases the conduction heat transfer in the x-direction and decreases the conductive heat transfer in the y-direction. Examination of the governing equations (Equation (2)) shows that the only heat transfer terms affected by cavity height are $Q_{f1\cdot x}^{cond}$ and $Q_{f1\cdot y}^{cond}$ (Equations (5) and (7)). Further studies show that changes in cavity height have an increasing effect on $Q_{f1\cdot x}^{cond}$ and a decreasing





effect on $Q_{f1:y}^{\text{cond}}$. Due to these factors, the cavity height variations do not significantly affect the temperature distribution. However, the investigation at different velocities shows that temperature difference is increased with the velocity variations at the channel's specified heights.

In Fig. 7, the temperature difference ratio $\left(\frac{\Delta\theta}{\theta_h}\right)$ was evaluated at different velocities and heater/sensor distance. Fig. 7 shows that the temperature difference decreases with heater/sensor distance increments at a constant velocity. Thus, with increasing D, the accuracy of sensor measurement improves. However, the results show that increasing the flow velocity at different heater/sensor distances increases the temperature difference ratio. Therefore, increasing the flow velocity will reduce the accuracy of the sensor measurement.



To determine the optimum thermo-resistive sensor configuration, an optimization process using a genetic algorithm has been performed at different flow velocities. The genetic algorithm optimization process is performed for different fluid flow velocities (as an input parameter) to achieve maximum sensitivity, and optimal geometry is determined for each velocity. The results of the optimization are shown in Table 5.

U (m/s)	D (µm)	L (µm)	$\theta_{\mathbf{h}}(\mathbf{k})$	w (μ m)	h (μm)	s (µm)	t (μm)
1	107.27	287.68	45.53	50.12	197.74	784.19	4.66
2	150.00	200.00	63.41	68.68	199.82	823.64	4.30
3	150.00	200.00	30.75	69.76	197.93	850.00	6.00
4	150.00	200.00	40.82	70.00	167.93	850.00	5.27
5	149.25	209.48	53.62	69.28	136.45	821.71	4.04
6	149.31	242.40	54.00	69.38	192.50	610.83	4.55
7	146.21	202.19	64.52	69.47	184.63	838.09	3.06
8	144.48	225.87	67.97	62.78	150.56	738.84	4.11
9	150.00	241.38	30.75	69.82	200.00	667.38	2.00
10	146.60	201.46	53.44	68.91	189.63	836.32	4.09

Table 5. Results of thermo-resistive sensor optimization.

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The optimization results (data bank) have developed analytical correlations using the curvefitting method. As a result, the optimum geometrical configuration of the thermo-resistive flow sensor can be derived simply for any velocity, using these analytical correlations.

$$D = -e^{-8}U^6 + 5e^{-7}U^5 - 7e^{-6}U^4 + 5e^{-5}U^3 - 0.0002U^2 + 0.0003U - 8e^{-5},$$
(28)

$$L = -2e^{-8}U^6 + 6e^{-7}U^5 - 7e^{-6}U^4 + 3e^{-5}U^3 - 1e^{-5}U^2 - 0.0002U + 0.0004,$$
(29)

$$W = -8e^{-9}U^6 + 3e^{-7}U^5 - 4e^{-6}U^4 + 2e^{-5}U^3 - 9e^{-5}U^2 + 0.0002U - 4e^{-5},$$
(30)

$$h = -2e^{-8}U^6 + 7e^{-7}U^5 - 9e^{-6}U + 7e^{-5}U^3 - 0.0002U^2 + 0.0004U - e^{-5},$$
(31)

$$s = 2e^{-7}U^6 - 7e^{-6}U^5 + 9e^{-5}U^4 - 0.0005U^3 + 0.0016U^2 - 0.0021U + 0.0018,$$
(32)

$$\theta_h = 0.0013U^6 + 0.059U^5 - 2.2292U^4 + 23.837U^3 - 105.99U^2 + 193.23U^1 - 62.212.$$
(33)

7. Conclusions

The analytical method was applied to analyze and optimize the thermo-resistive microcalorimetric flow sensor in the current paper. The differential energy balance equation, including convection/conduction terms and temperature-dependent thermal conductivity, is derived in the first step. Then, the famous analytical method, the so-called differential transformation method, has been used for an analytical solution. The sensitivity analysis using an analytical solution shows that sensor sensitivity was increased with flow velocity decrements, film thickness decrements, and heater-sensor distance increments. In the final step, the geometrical optimization of the thermo-resistive sensor has been performed using the genetic algorithm method at different flow velocities. The different analytical correlations have been presented based on optimization data (at different velocities) for the optimum geometrical parameter. Using these analytical geometrical parameters, an optimum configuration can be specified analytically for any flow velocity.

Nomenclature

- 2s length of the bare TMCF sensor chip (μ m)
- 2*L* partially heated length (μ m)
- 2W length of heater (μ m)
- *D* sensor distance from the heater (μ m)
- *h* cavity height (μ m)
- T temperature (K)
- *t* thin-film thickness (µm)
- *K* thermal conductivity (W/mK)
- U flow velocity (m/s)
- S_m sensitivity (K/(m/s))
- cond conduction heat transfer
- conv convection heat transfer
- Pr Prandtl Number
- *u* upstream
- d downstream

Subscript

- h heater
- f moving fluid on the top of the thin film
- *f*1 fluid in the cavity
- *s* thin film
- *w* the working temperature of the microheater

Greek letters

- δ momentum boundary layer
- δ_t thermal boundary layer
- θ temperature variable change
- μ viscosity



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